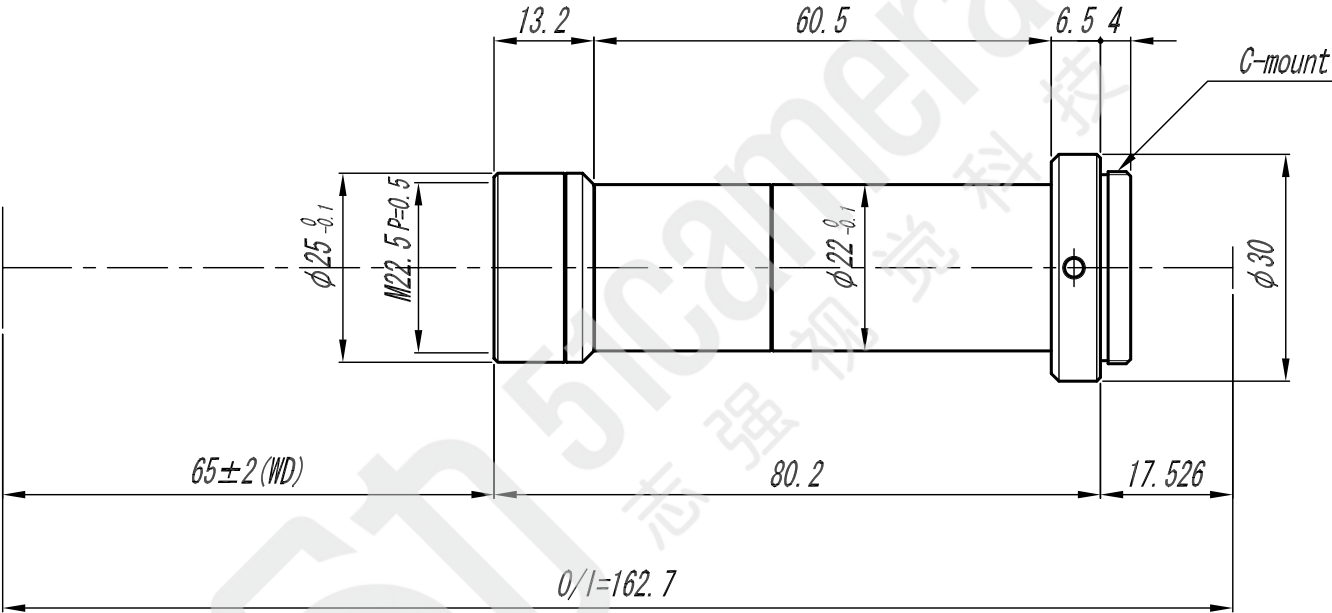




△				APPROVED	CHECKED	MATERIAL 材料				CHAMFER 一般面取				QUANTITY 個數				
△				T. A.	T. A.	TREATMENT 処理				FINISHING 仕上								
△						TREATMENT CONTACT 処理接点				DECENTRATION 偏芯								
△				DESIGNED	DRAWN	OVER 250 UP TO 1000	±0.3	±0.5	±1.0	±0.2	UNIT (mm)	ANGLE 角度	METHOD 図法	REMARK 適用 (機種名)				
△						OVER 63 UP TO 250	±0.2	±0.3	±0.6	±0.15				VS-TCH2-65				
△				T. A.	S. K.	OVER 16 UP TO 63	±0.1	±0.2	±0.4	±0.1	SCALE	1 / 1		NAME	外 観 図			
						OVER 0 UP TO 16	±0.05	±0.1	±0.2	±0.1				DRAW NO.	ODT C0420A1			
	DATE	EXCH NO.	REVISION 変更記事			TOLERANCES				A	B	C	S	DATE	'09.04.03			